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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 1256**
Yoshihiro GUNJI et al. : Docket No. 2001-1075A
Serial No. 09/917,732 : Group Art Unit 1763
Filed July 31, 2001 : Examiner Sylvia MacArthur

SUBSTRATE HOLDING APPARATUS AND
SUBSTRATE POLISHING APPARATUS

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of December 22, 2003, the period for response to which having been extended by one month to April 22, 2004, kindly amend the above-referenced U.S. patent application as follows: